

Atty Docket No. JCLA12157

Serial No. 10/605,478

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: Wilson, Christian D.

Group Art Unit: 2824

In re PATENT APPLICATION of

Applicants : Hsiu-Chuan Chu)

Serial No. : 10/605,478)

Filed : October 02, 2003)

For : Silicon Oxide Gap-Filling Process)

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MAY 24 2005

AMENDMENTAMENDMENT AND RESPONSE TO OFFICE ACTION

MAIL STOP Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action mailed November 24, 2004, has been carefully considered. In response thereto, please enter the following amendment and consider the following

05/26/2005 EFLORES 00000136 500710 10605478

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